

# Status of MLLTRAP

1. Status of MLLTRAP
2. Calculations for RFQCB
3. Emittance measurements

**Sophie Morard**

**Laboratoire de physique des 2 infinis Irène Joliot Curie**

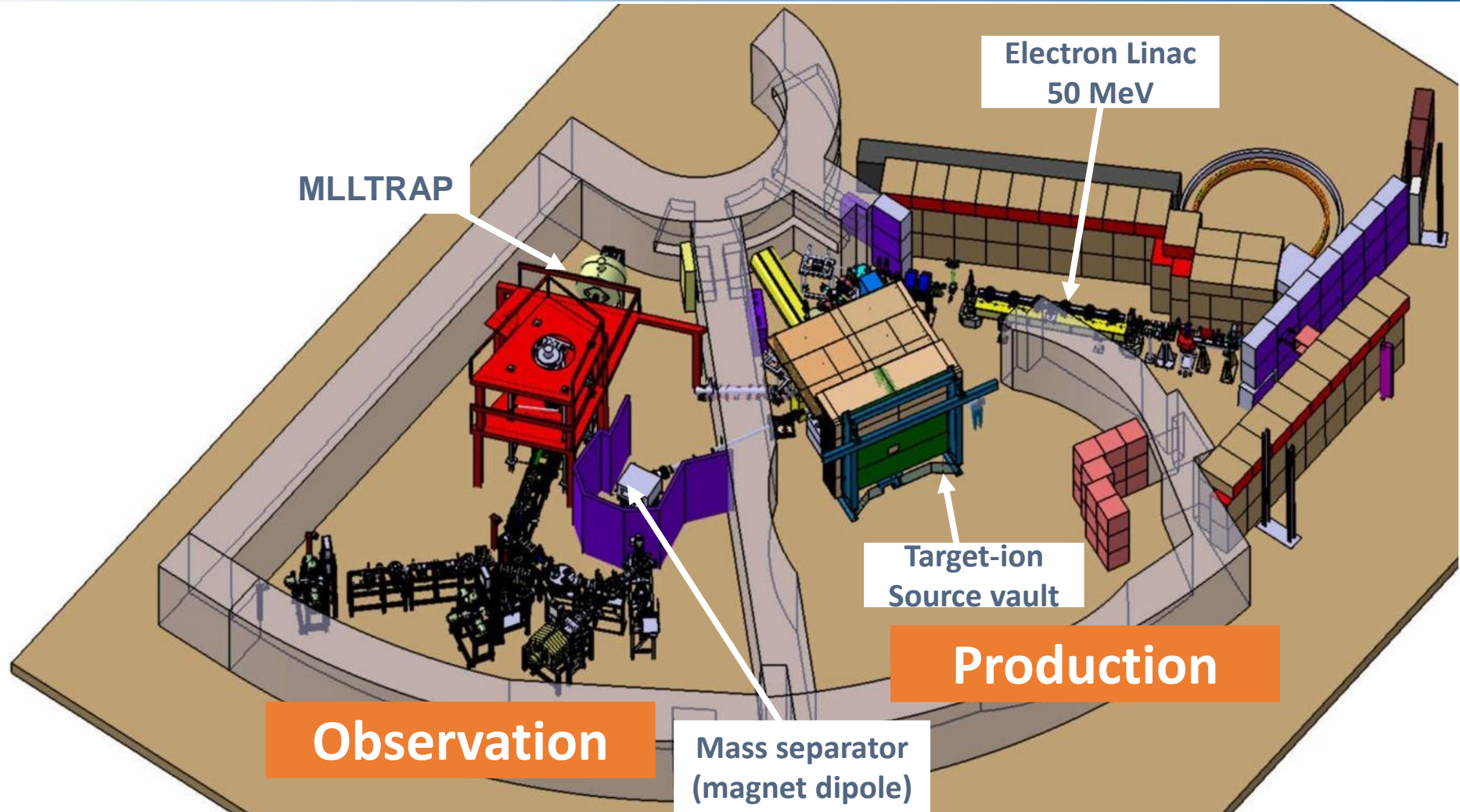
Supervisors :

Luc Perrot & Enrique Minaya Ramirez





# ALTO-LEB : Accélérateur Linéaire & Tandem d'Orsay – Low Energy Beam





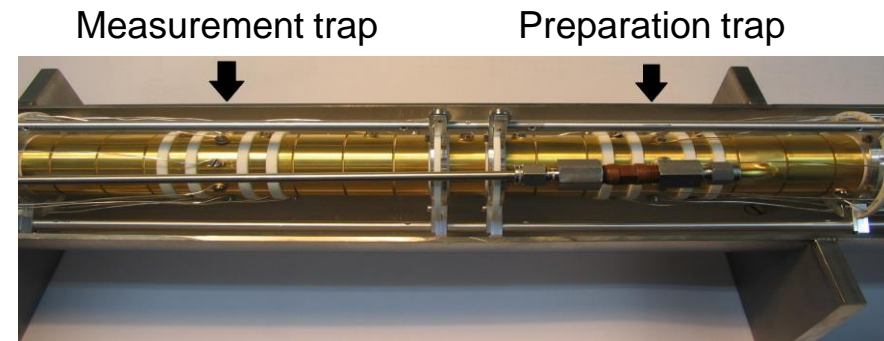
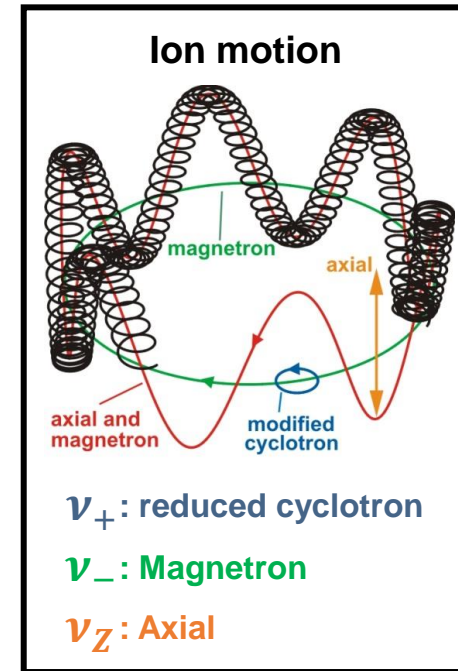
# MLLTRAP : Maier-Leibnitzen Laboratory Trap

## Double Penning trap spectrometer

- Penning trap : superposition of high magnetic field and low electrostatic field to confine in 3D
- Preparation trap : Isobaric separation with buffer gas cooling
- Measurement trap : Cyclotron frequency measurements

$$\nu_c = \frac{qB}{2\pi m}$$

7T superconducting magnet

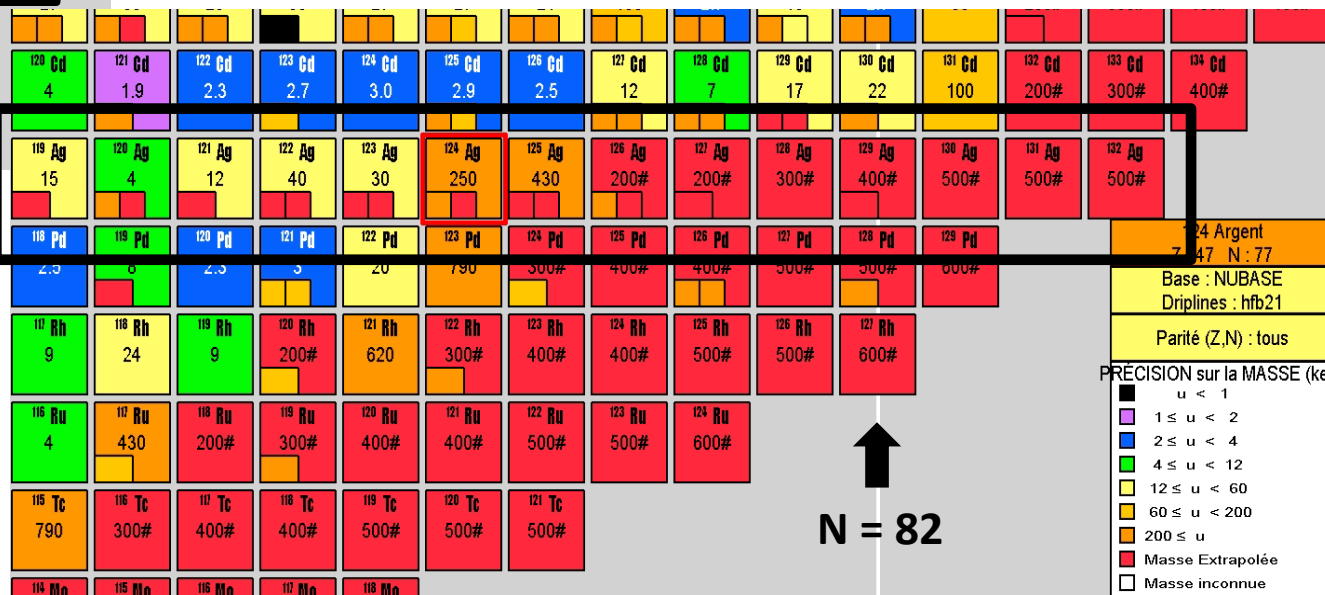
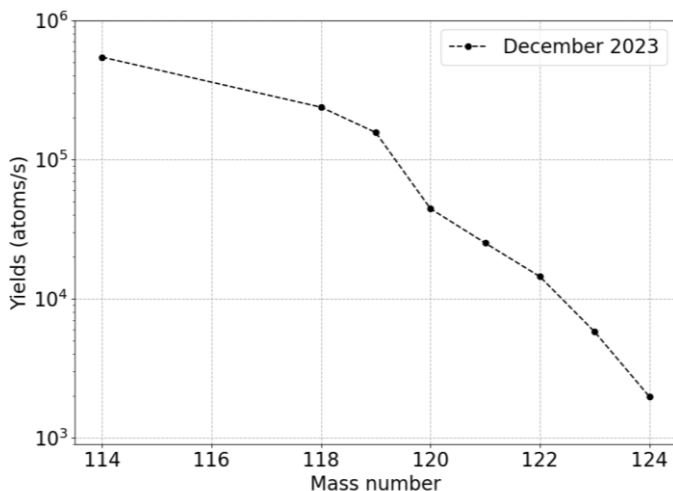
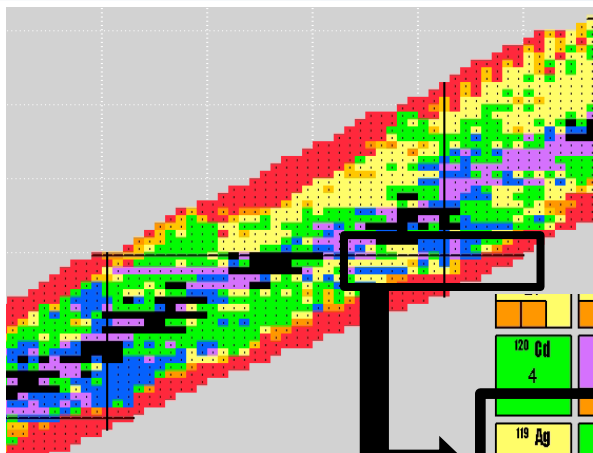
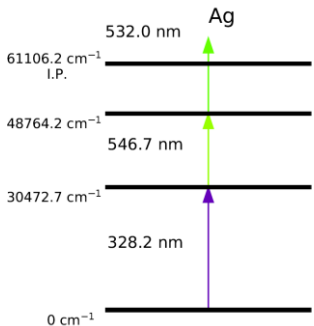




# MLLTRAP – Physical case at ALTO-LEB

## Study of Silver isotopes :

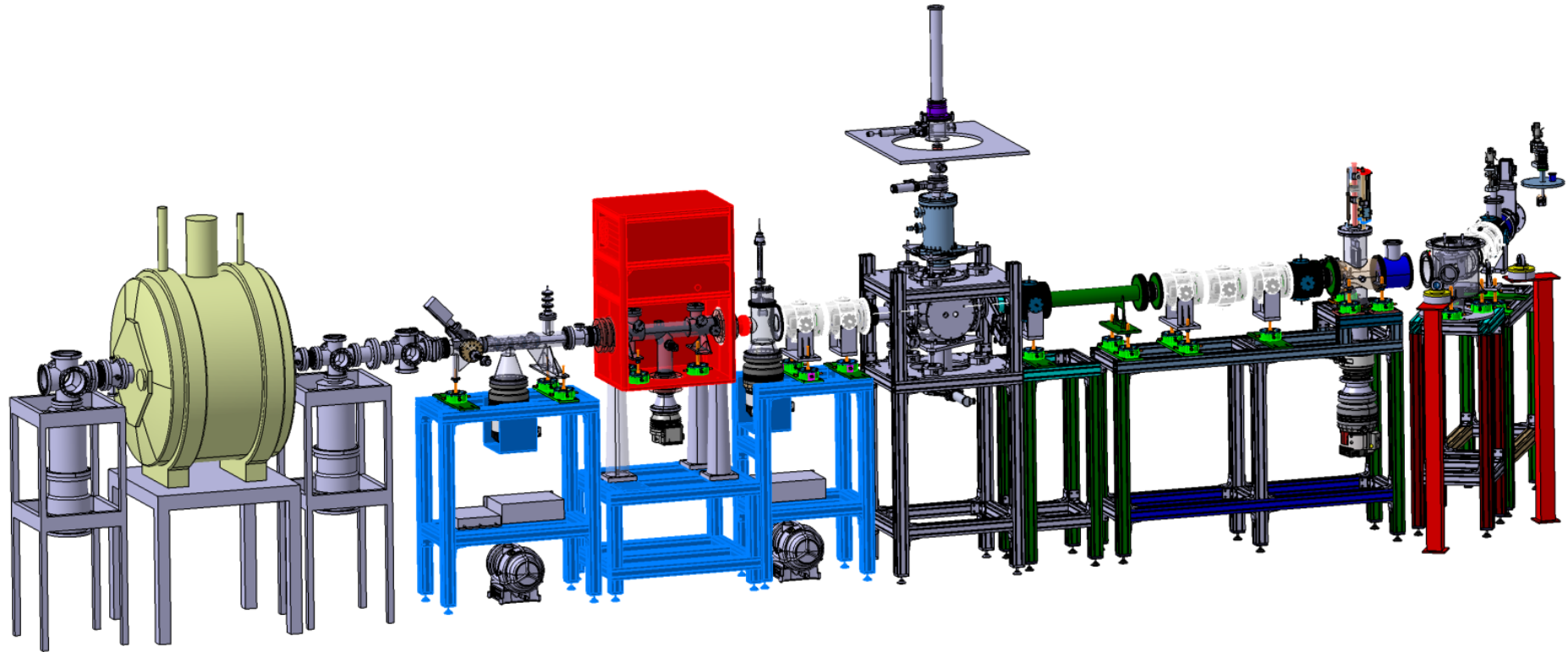
- N = 82 shell closure
- Access to binding energy
- Better understanding of nuclear structure



Production of Silver atoms at ALTO-LEB

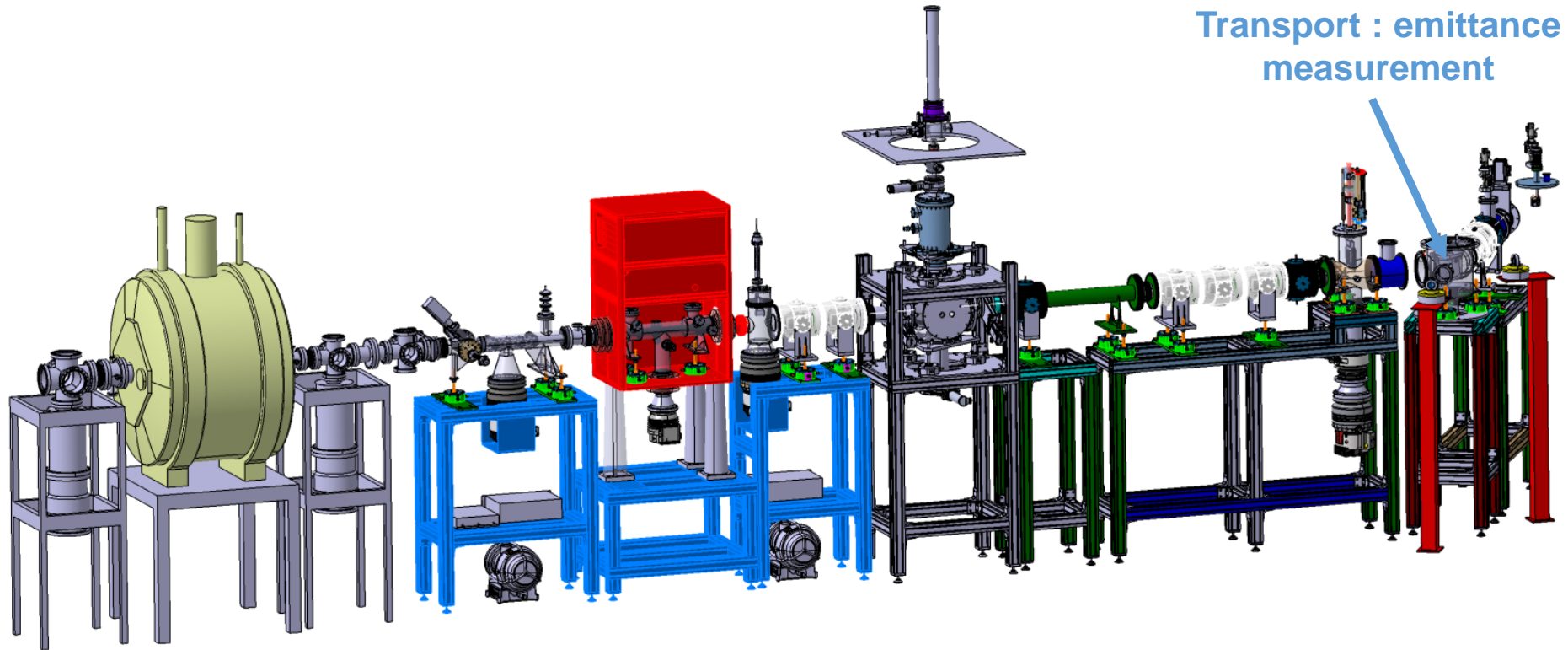


# MLLTRAP – Transfer Line



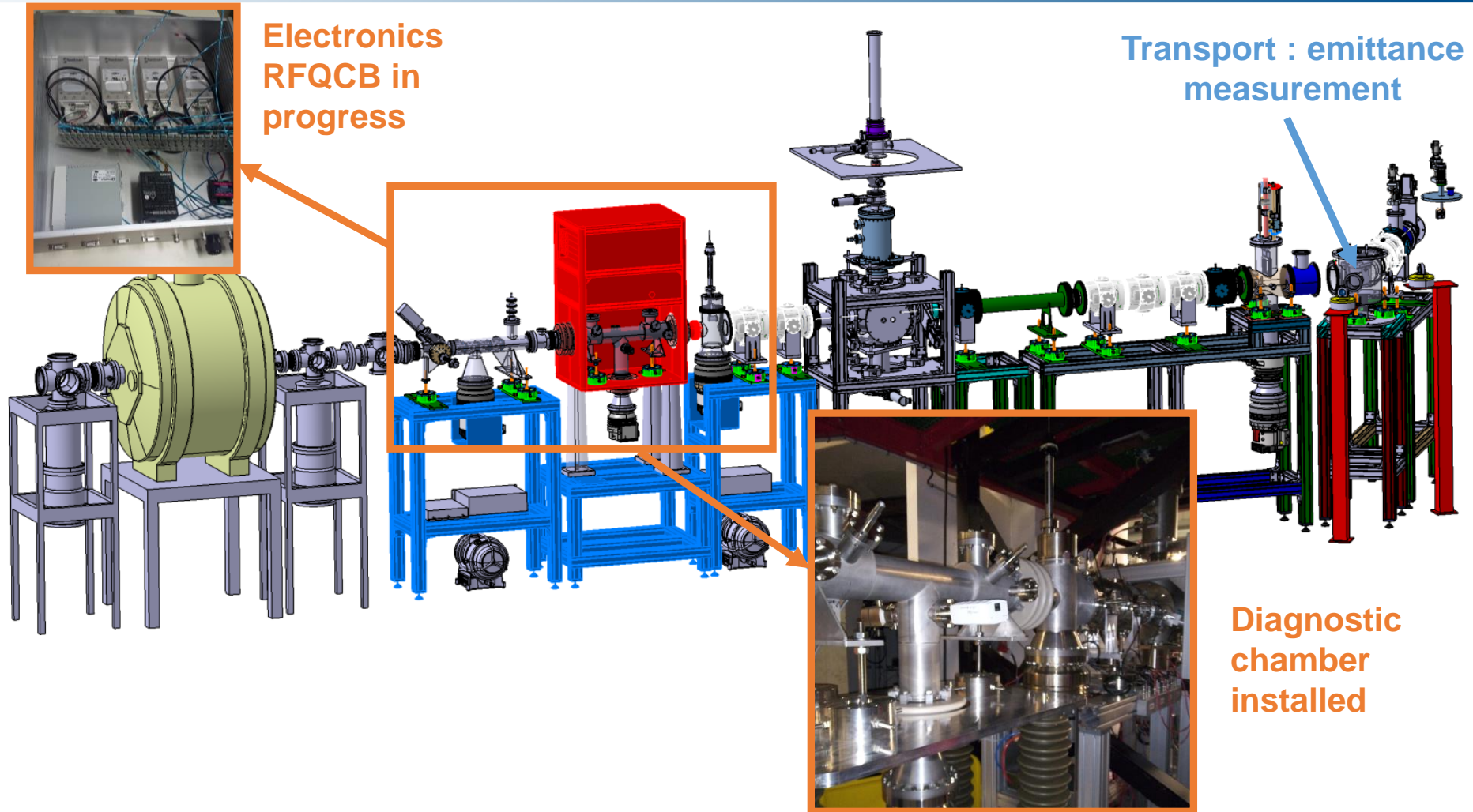


# MLLTRAP – Transfer Line



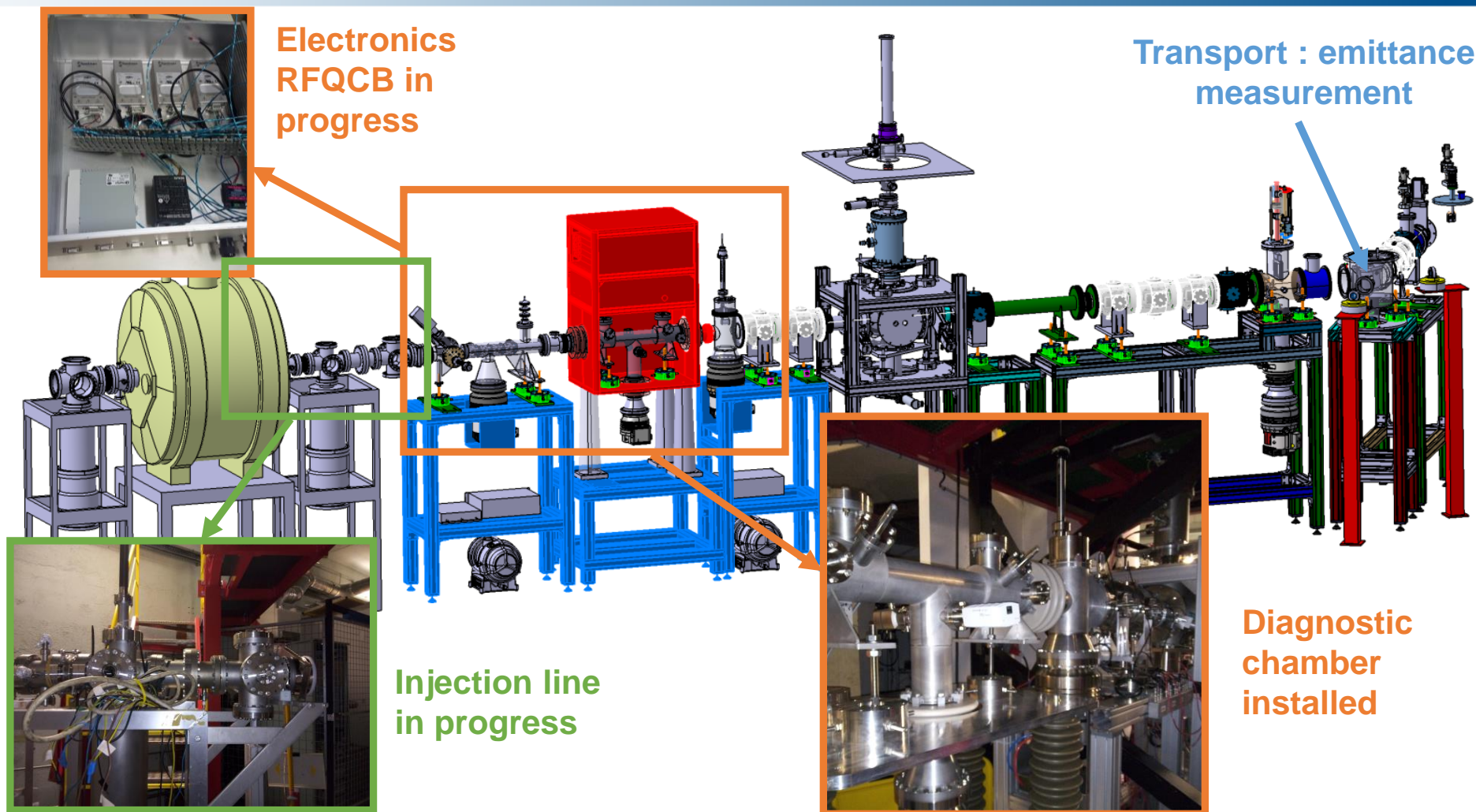


# MLLTRAP – Transfer Line





# MLLTRAP – Transfer Line







## Temperature stabilisation

- First design failed
- Second one in progress





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- Second one in progress



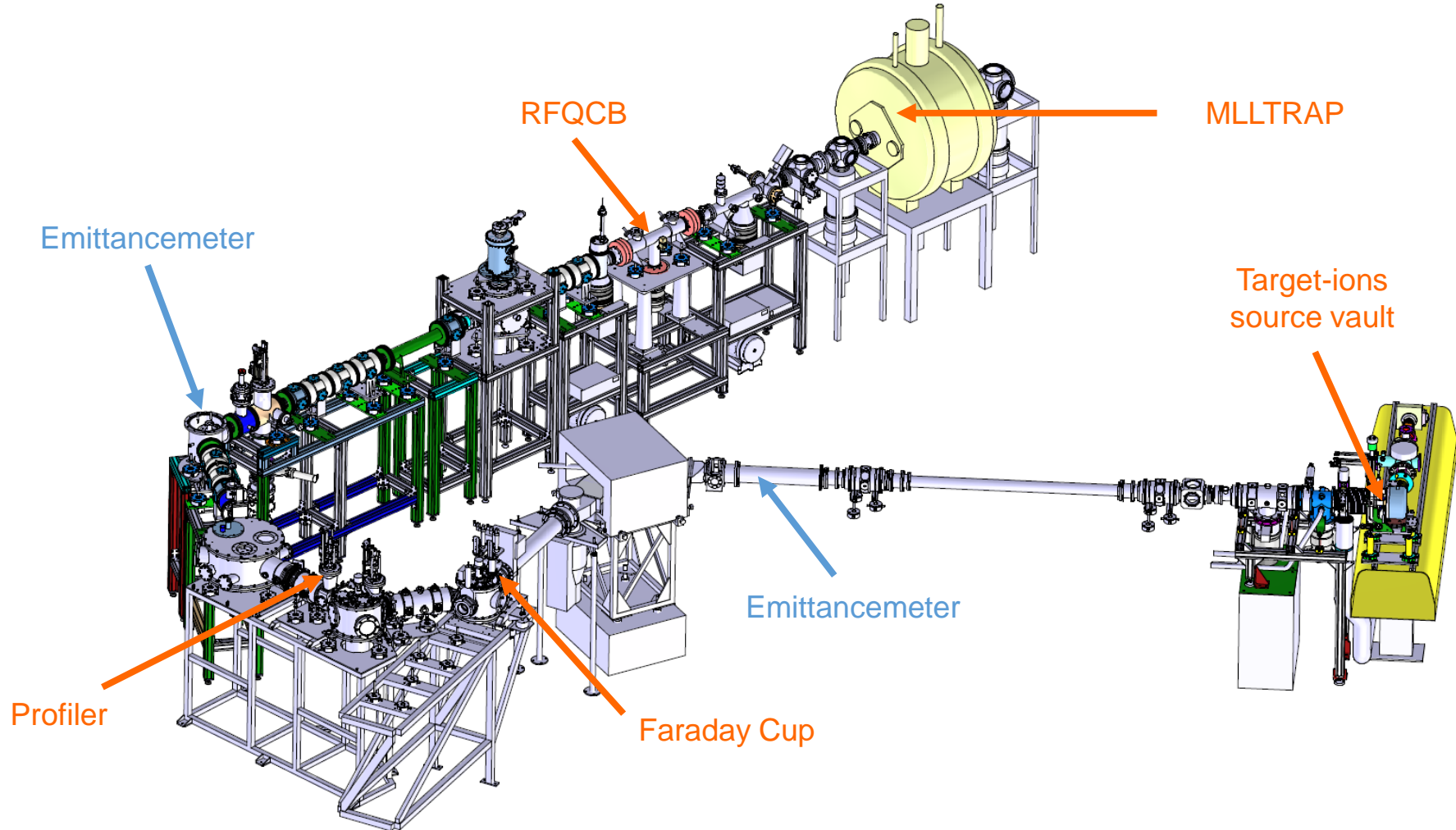
## Helium recovery line

- Installed and tested in May with POLAREX
- Soon connected to MLLTRAP



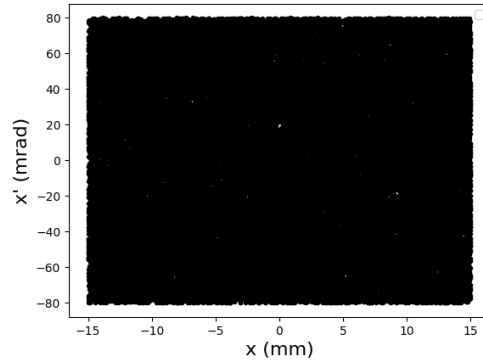


# Emittance measurements



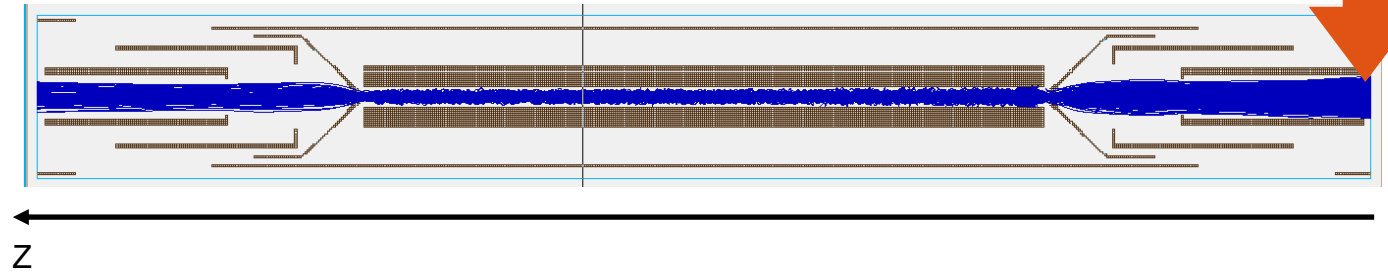
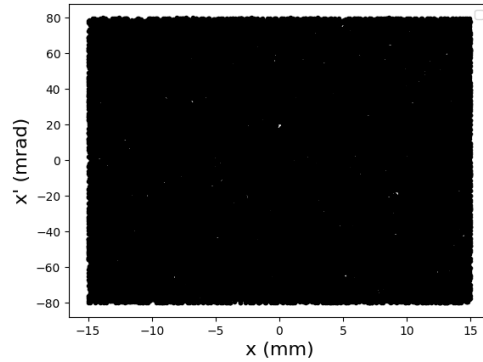


- Finding the acceptance



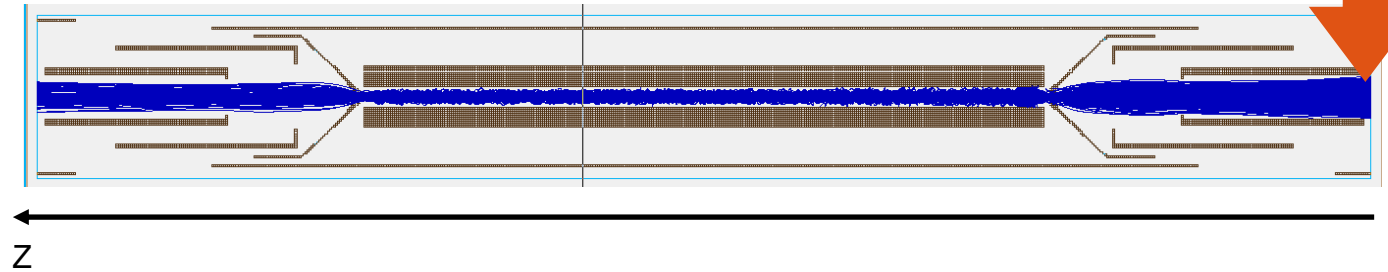
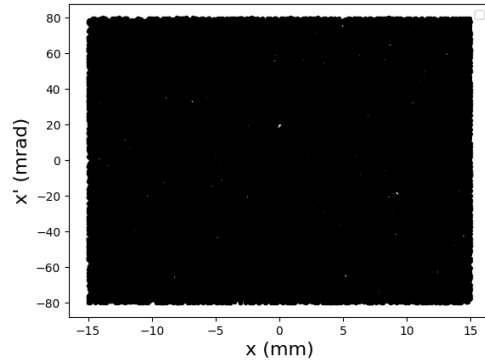


- Finding the acceptance





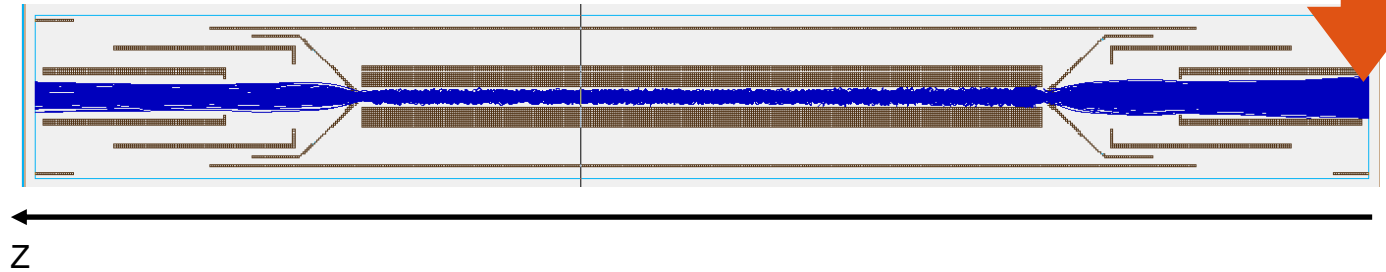
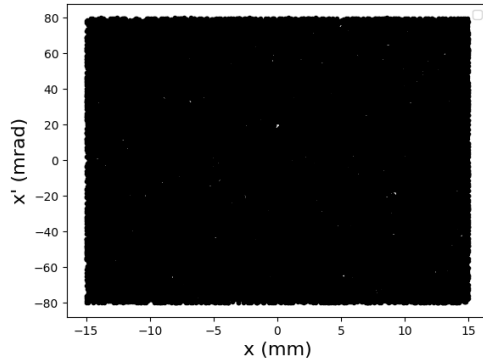
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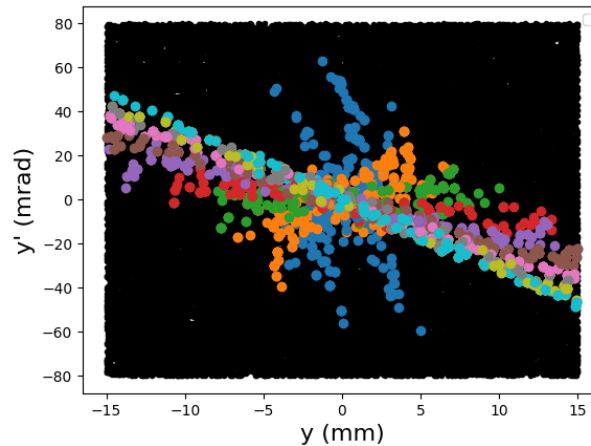
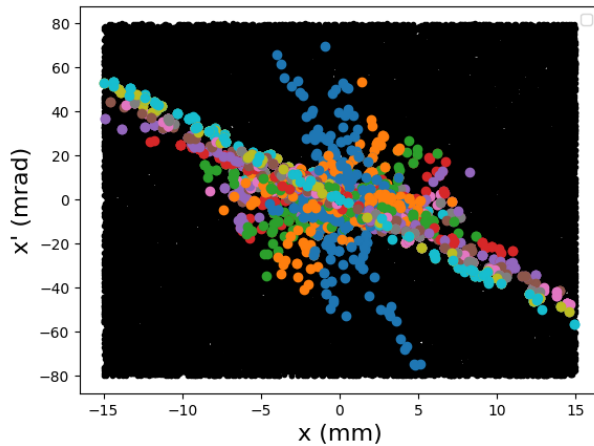
- Applied voltage on injection and ejection (First electrode 29975 V)



- Finding the acceptance



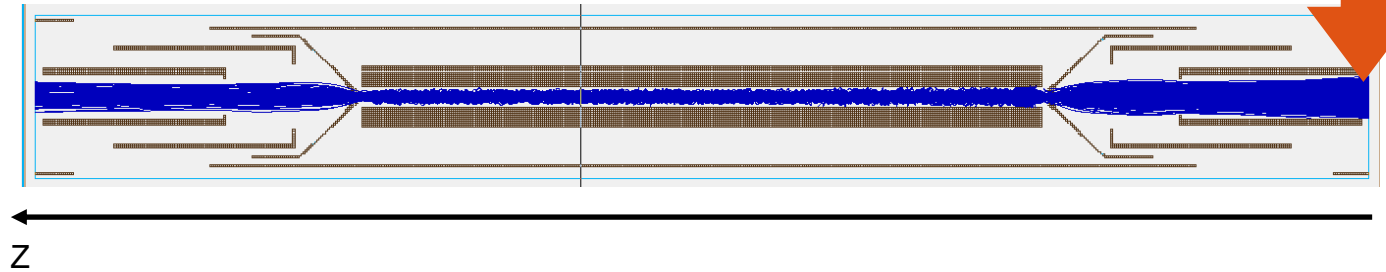
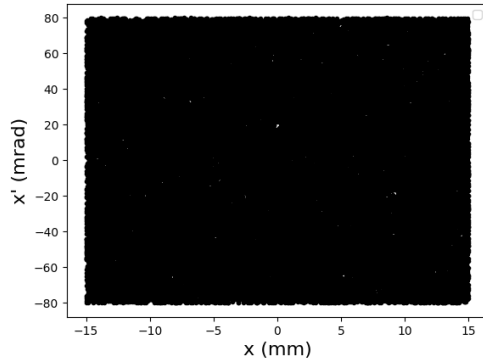
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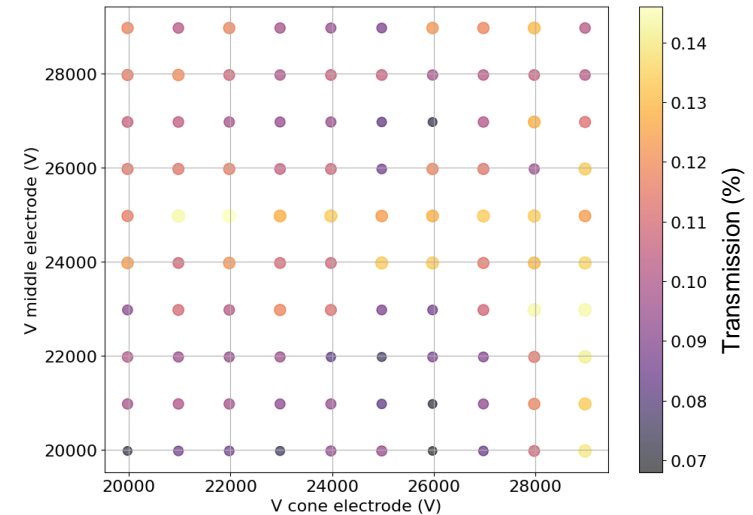
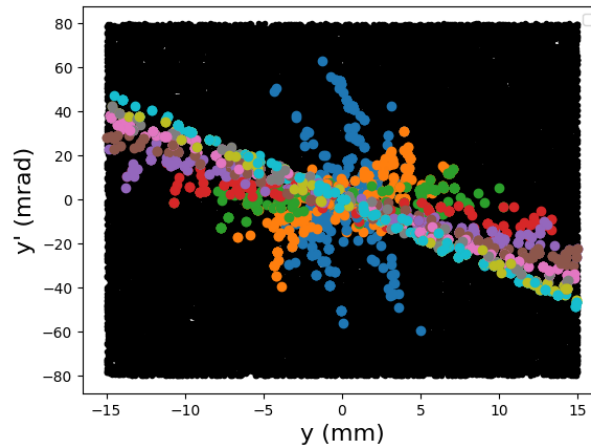
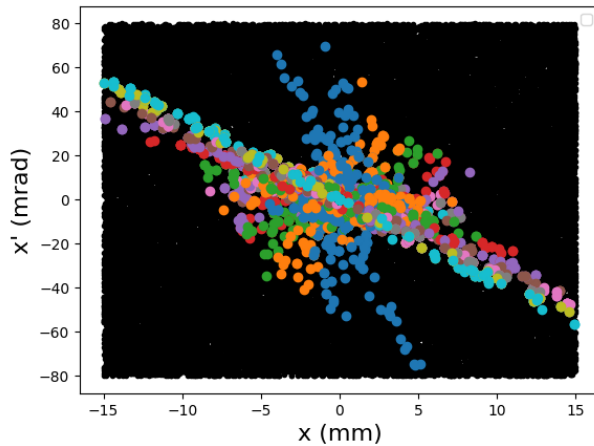


# MLLTRAP – Calculations for RFQCB

- Finding the acceptance



- Applied voltage on injection and ejection (First electrode 29975 V)

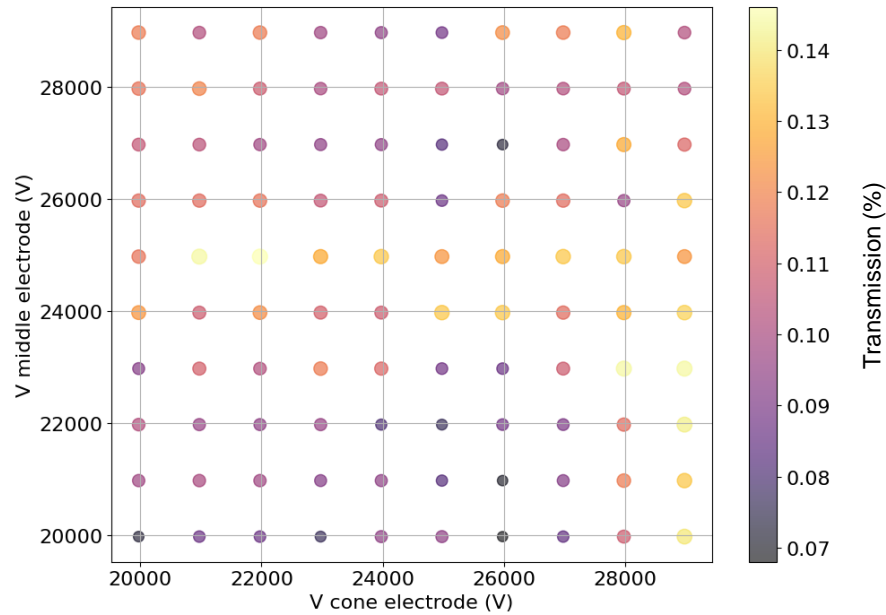






## Gas pressure optimisation :

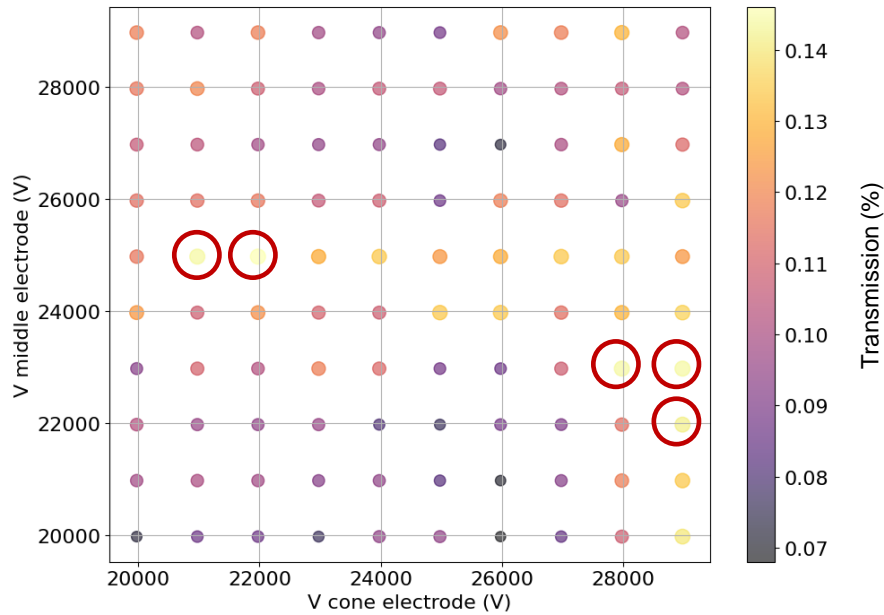
- 5 cases studied : best transmission
- Initial distribution : Ellipse of acceptance of 50000 particles





## Gas pressure optimisation :

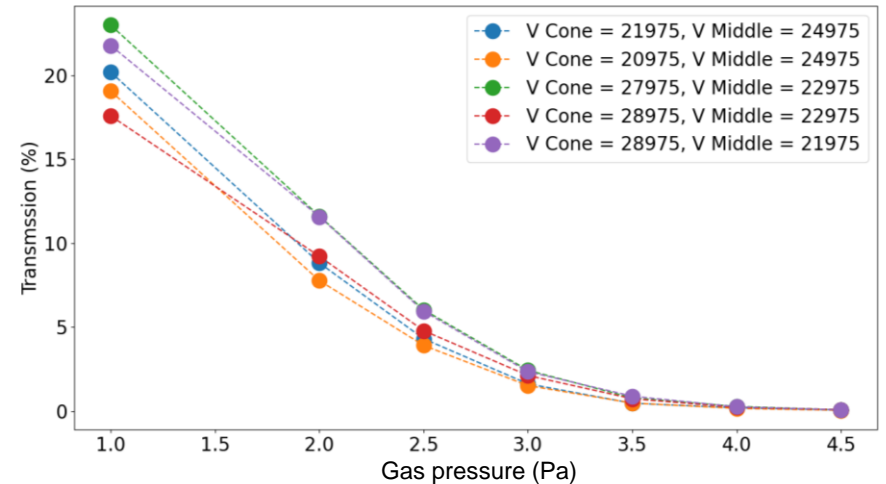
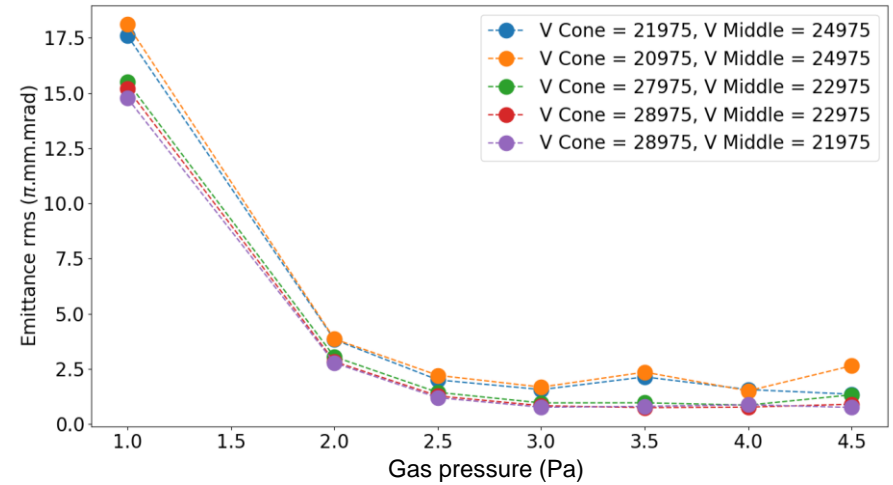
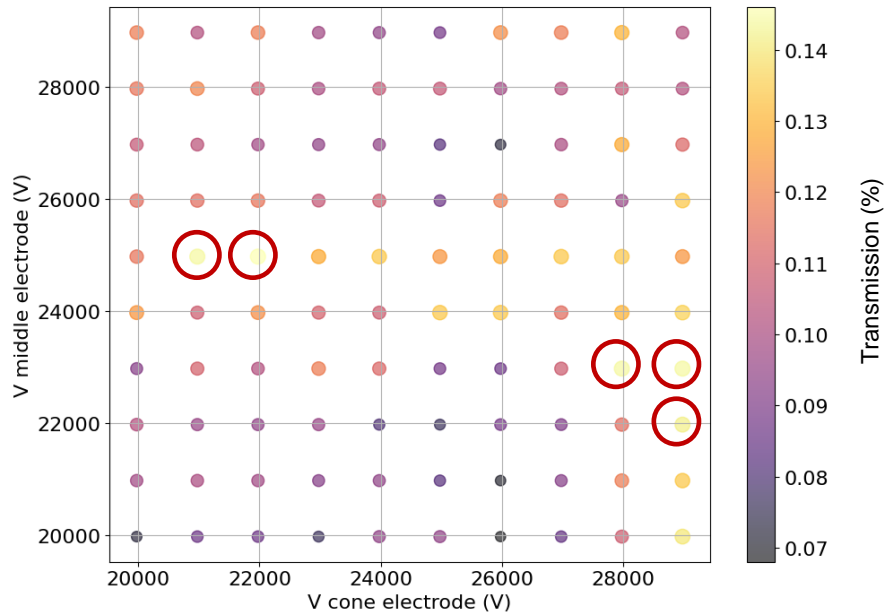
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## Gas pressure optimisation :

- 5 cases studied : best transmission
- Initial distribution : Ellipse of acceptance of 50000 particles

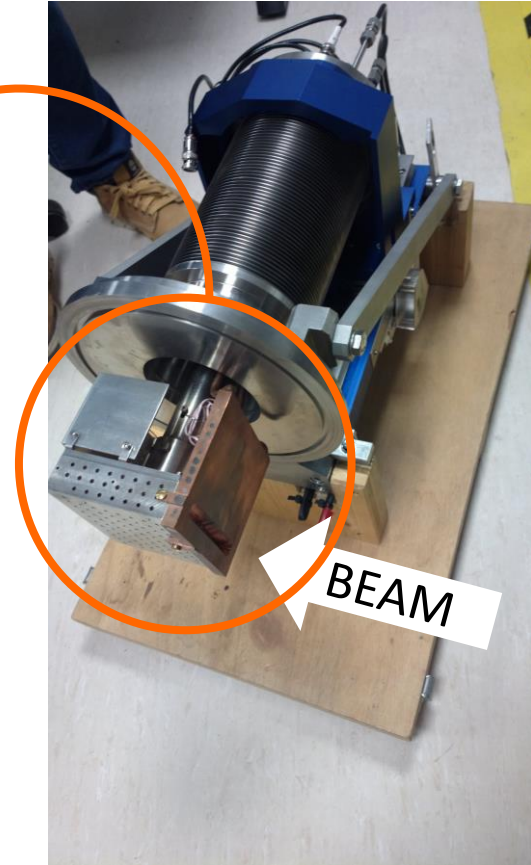
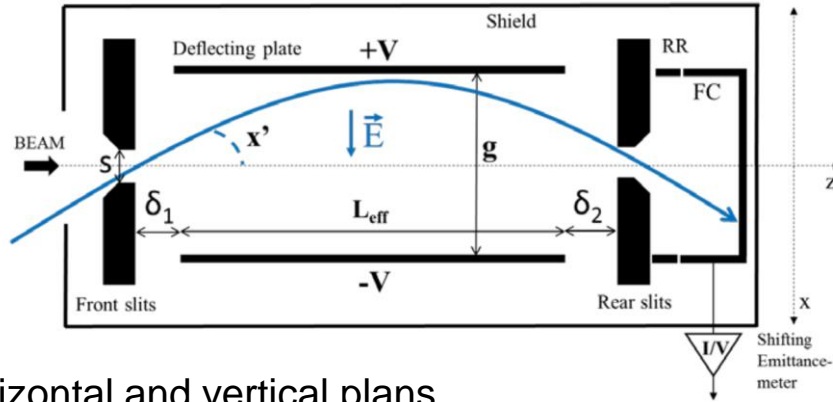




# Allison emittancemeter



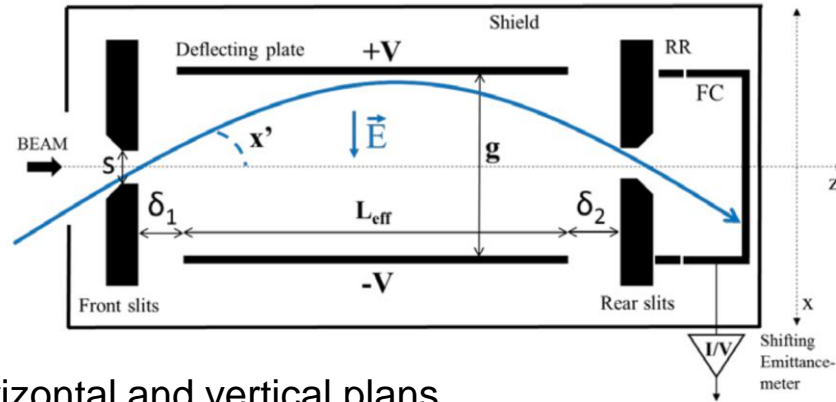
$$x' = \frac{\Delta V}{4Ug} \frac{L_{eff} + 2\delta_2}{\delta_1 + L_{eff} + \delta_2}$$



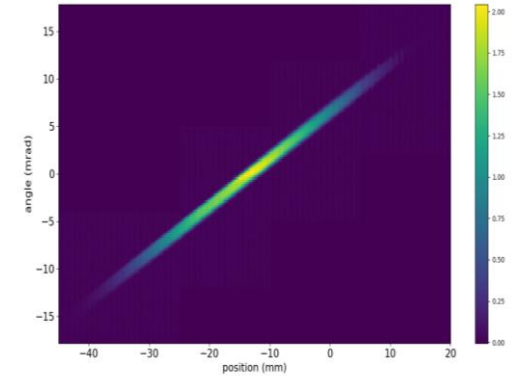
- 2D measurements in horizontal and vertical plans



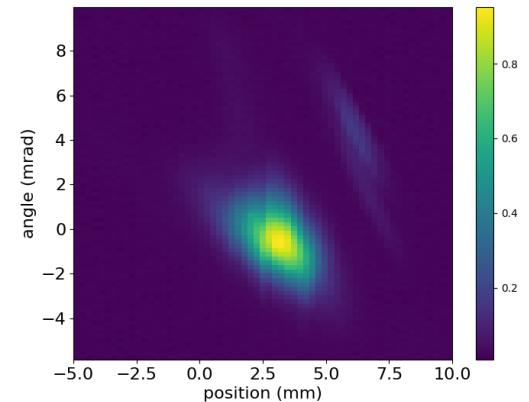
# Allison emittance meter



Measurement of horizontal phase space



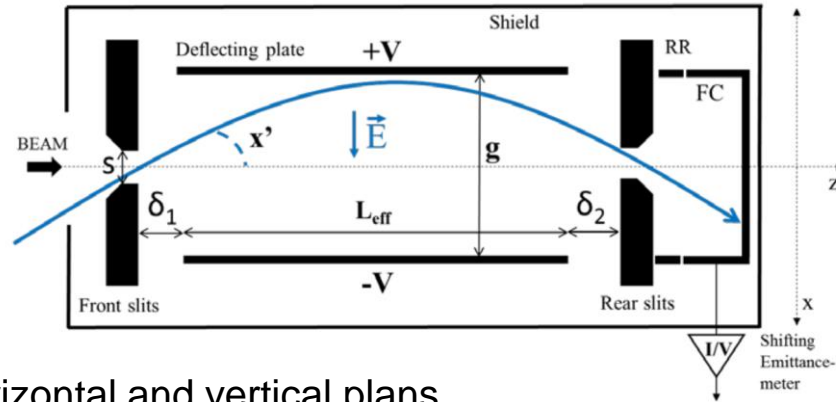
Measurement of vertical phase space



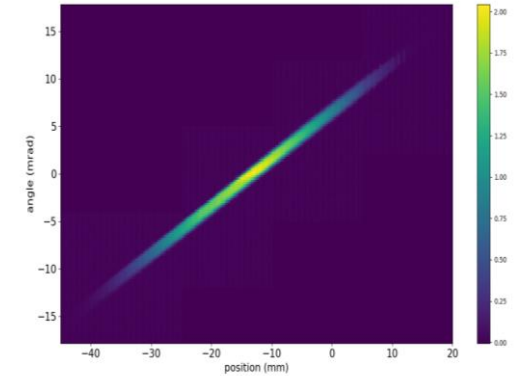
- 2D measurements in horizontal and vertical plans



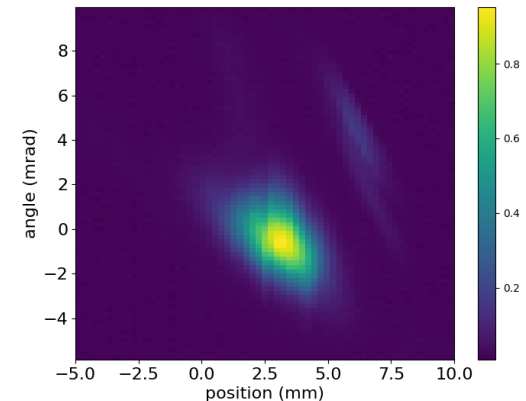
# Allison emittancemeter



Measurement of horizontal phase space



Measurement of vertical phase space



- 2D measurements in horizontal and vertical plans
- Parametric studies:
  - Error of emittancemeter : Measurement steps
  - Focusing effect : Quadrupoles voltage
  - Sensitivity of target-ions source vault : Position of extraction electrode and temperature of oven



## Results of parametric studies : Step of measurements

T\_acceleration (kV)  
30

Position initiale (mm)  
-8

Position finale (mm)  
16

Pas de position (mm)  
0,25

Nb positions  
97

HT max (V) Angle max  
140 14

HT min (V) Angle min  
20 2

HT step (V) Angle step  
2 0,1

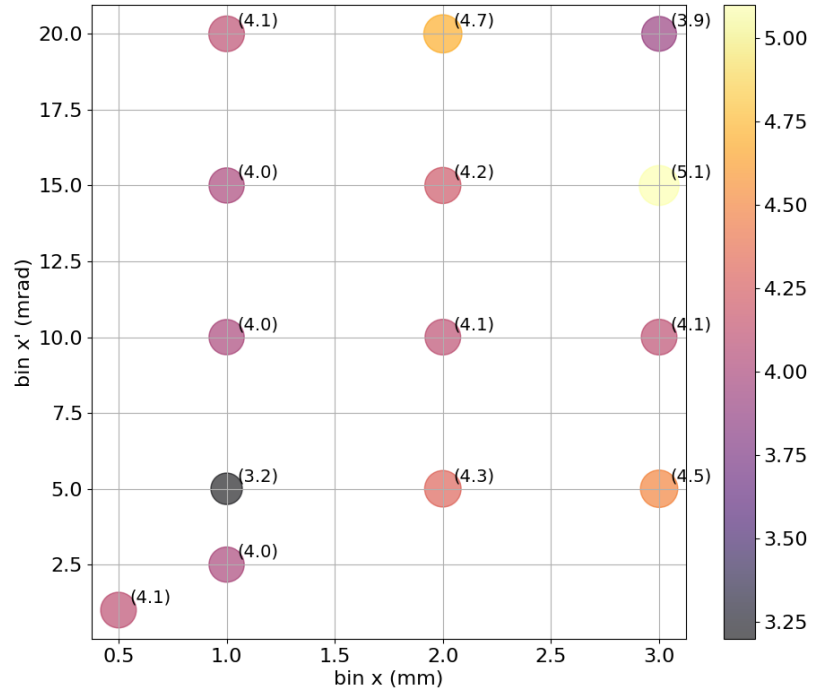
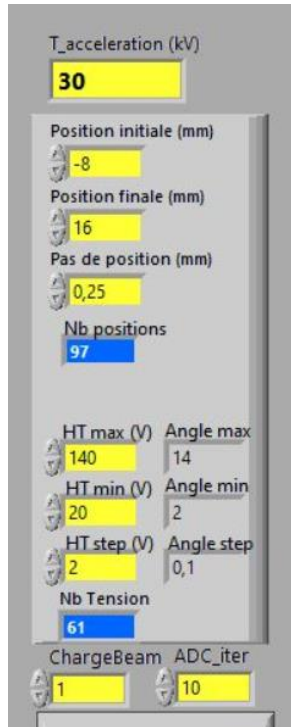
Nb Tension  
61

ChargeBeam ADC\_iter  
1 10

*Part of control command  
interface of Emittancemeter*



# Results of parametric studies : Step of measurements

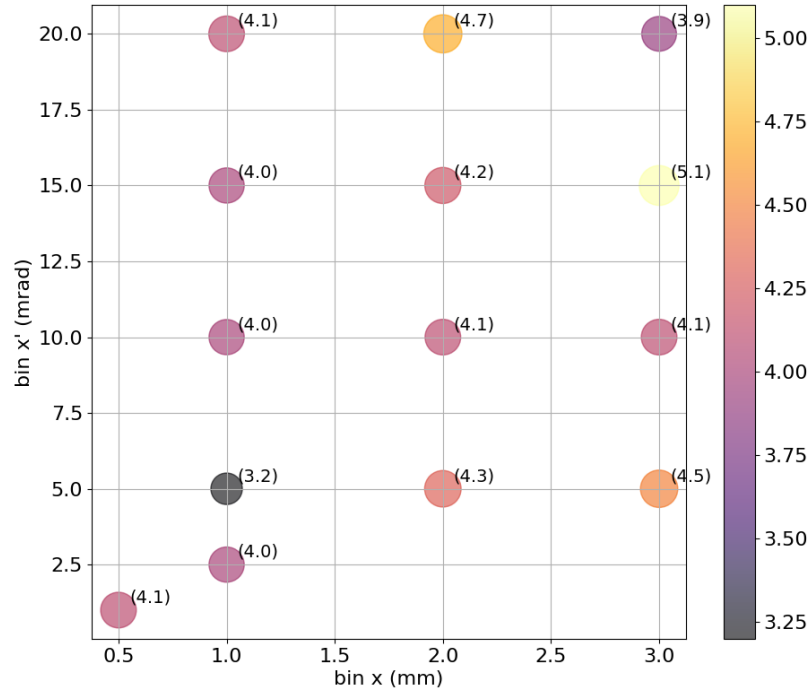
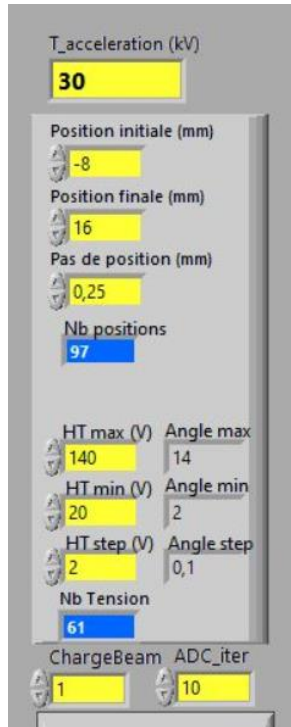


*Part of control command interface of Emittancemeter*





# Results of parametric studies : Step of measurements



Mean =  $4.2 \pi. mm. mrad$

Standard deviation =  $0.4 \pi. mm. mrad$



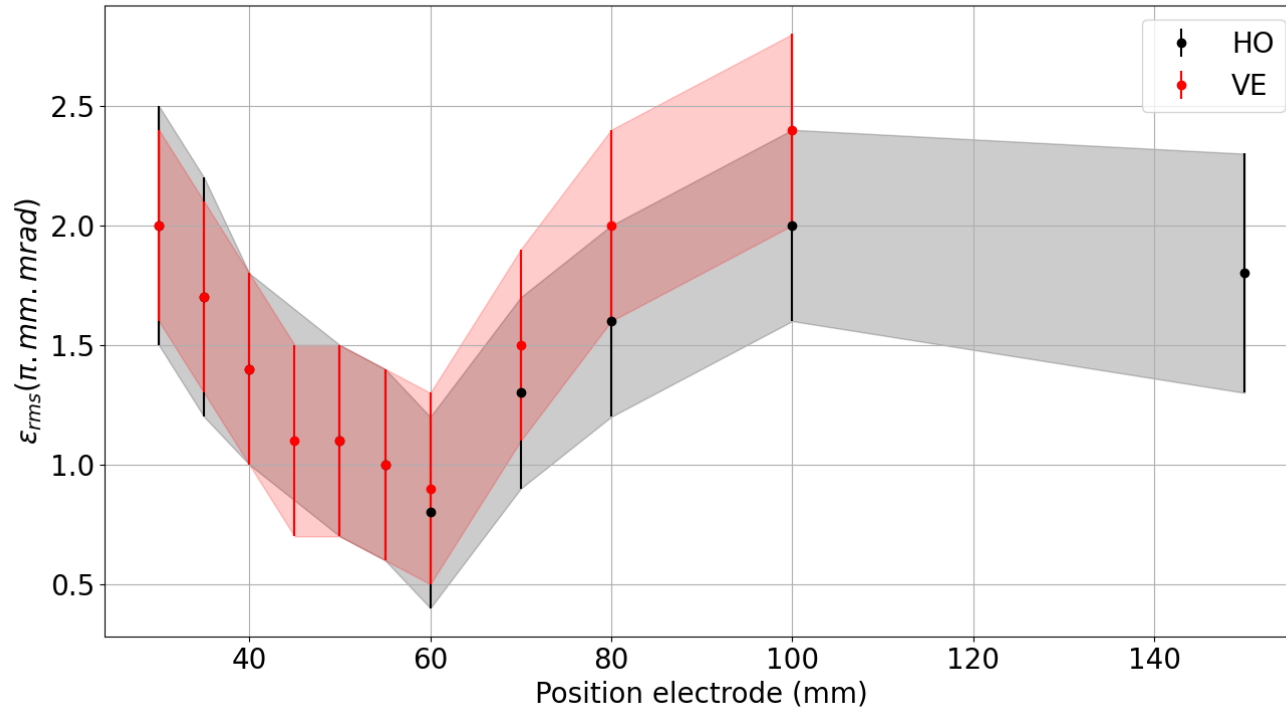
Error due to step of measurement

Final error :  $\delta\varepsilon = \sqrt{\delta_{fit}^2 + \delta_{step}^2}$

Part of control command interface of Emittancemeter



## Results of parametric studies : Position of extraction electrode

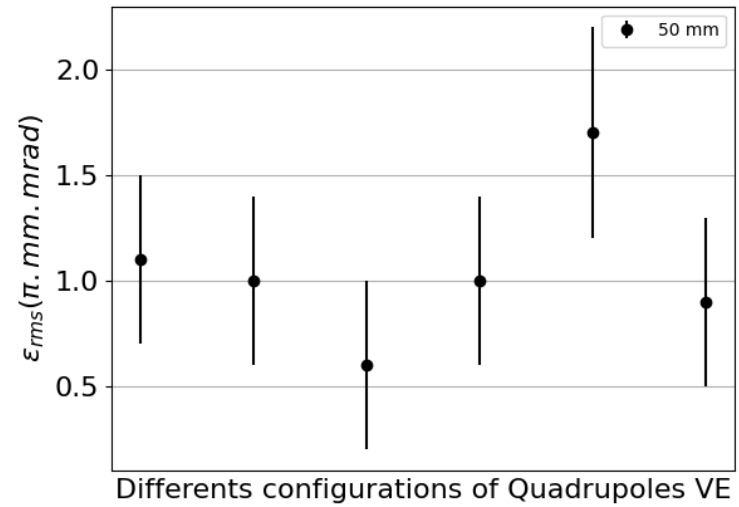


➔ Minimum of emittance at position 60 mm in both plans



# Results of parametric studies : Voltage on quadrupoles

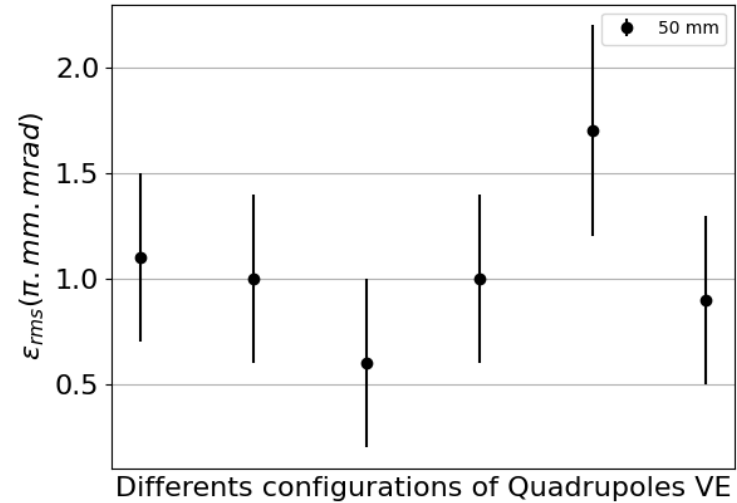
*Vertical plane*



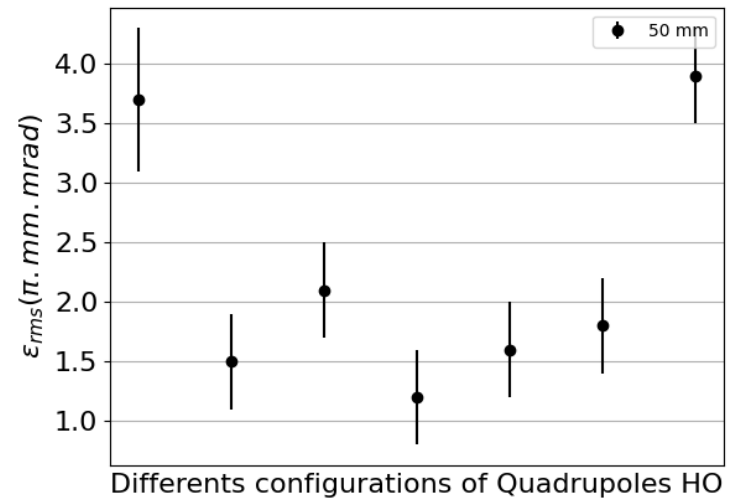


# Results of parametric studies : Voltage on quadrupoles

*Vertical plane*



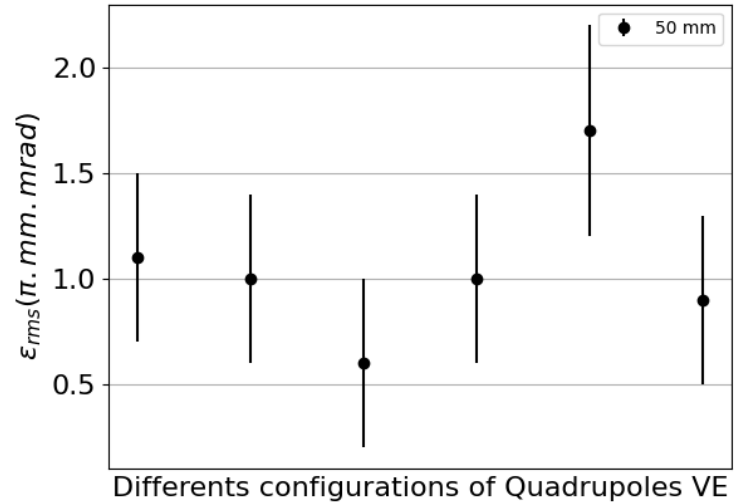
*Horizontal plane*



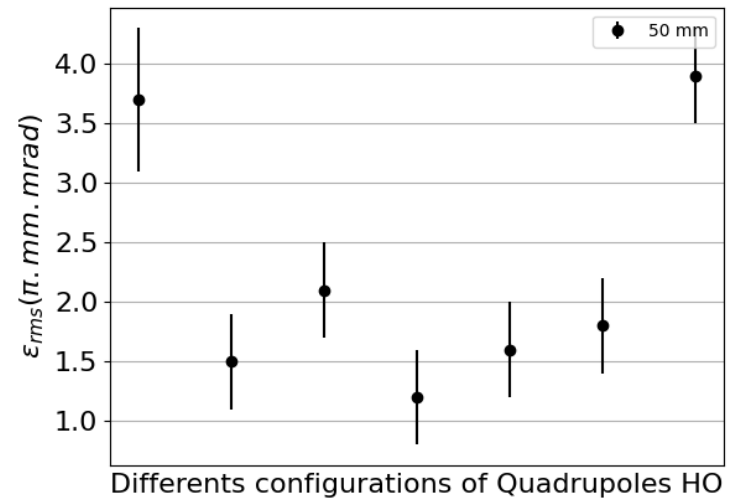


# Results of parametric studies : Voltage on quadrupoles

Vertical plane



Horizontal plane

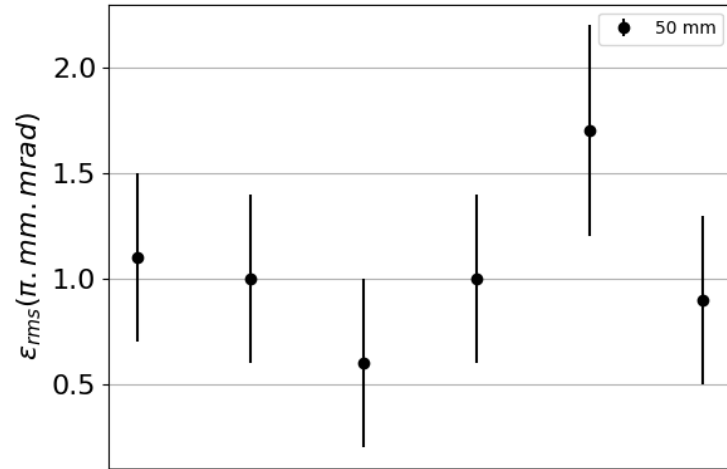


**Problem : Emittance not conservative**



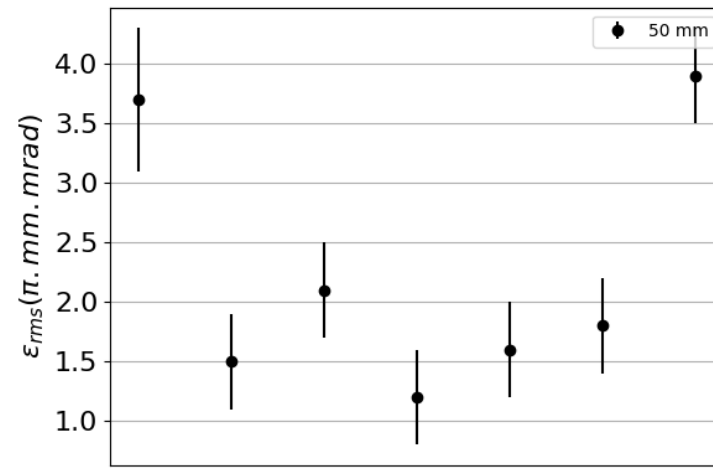
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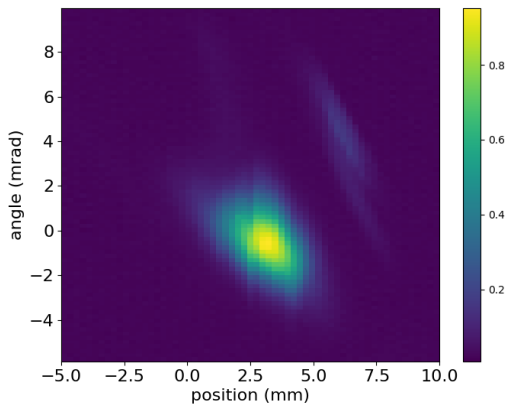


Differents configurations of Quadrupoles VE

Horizontal plane

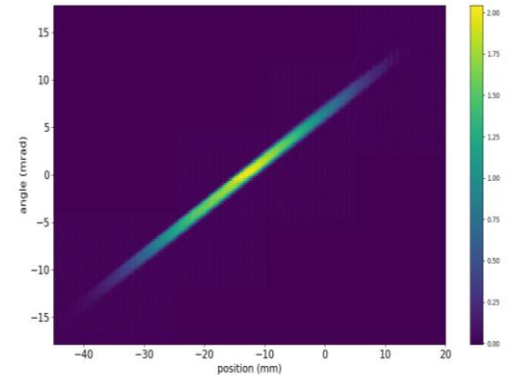


Differents configurations of Quadrupoles HO



**Problem : Emittance not conservative**

Influence of the shape of the beam on the analysis ?

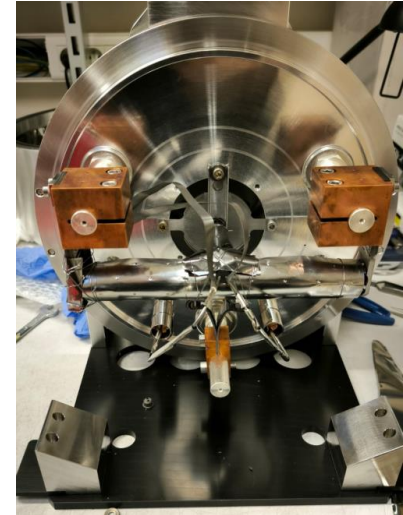




## Results of parametric studies : Oven current

Study of target-ion source different :

- Additional oven withdraw
- Target of C doped with Cs used in oven to simulate radioactive beam



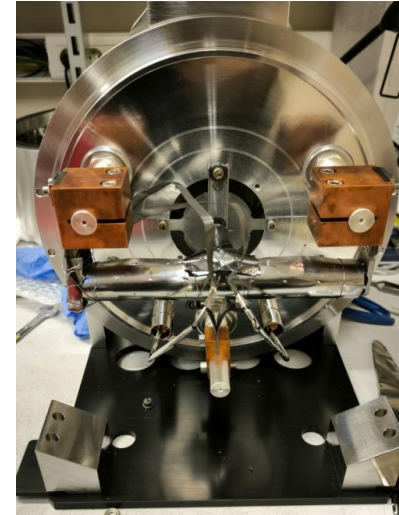
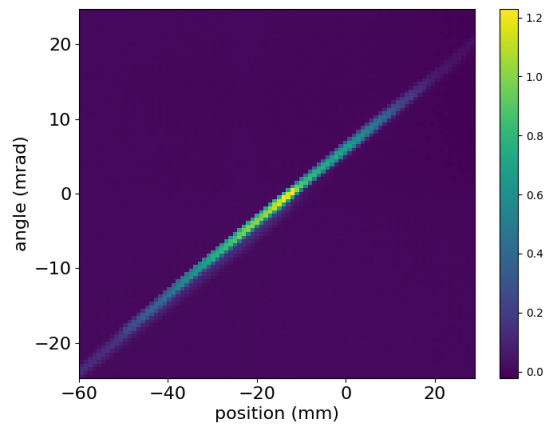


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*« Large » beam  
in Horizontal plan*





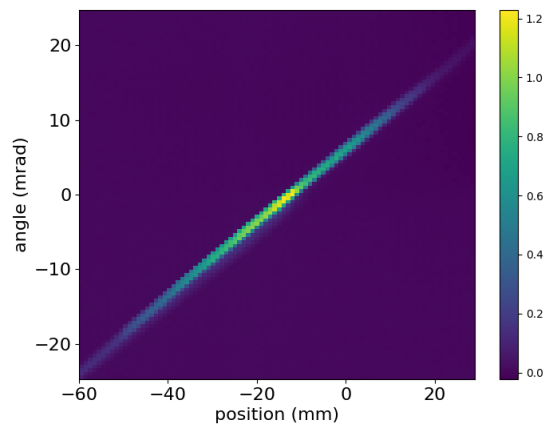


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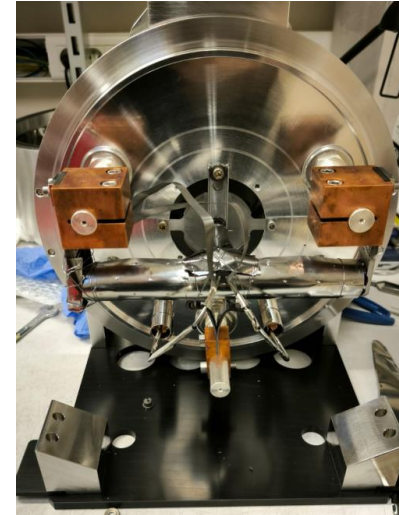
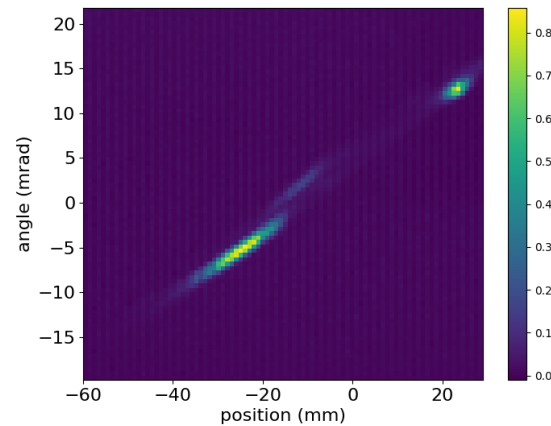
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*« Large » beam  
in Horizontal plan*



*« Small » beam  
in Horizontal plan*



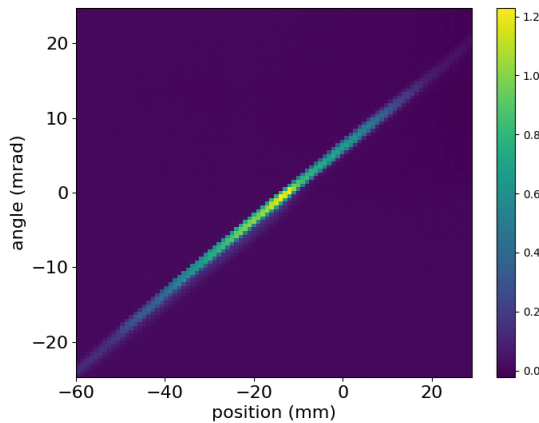


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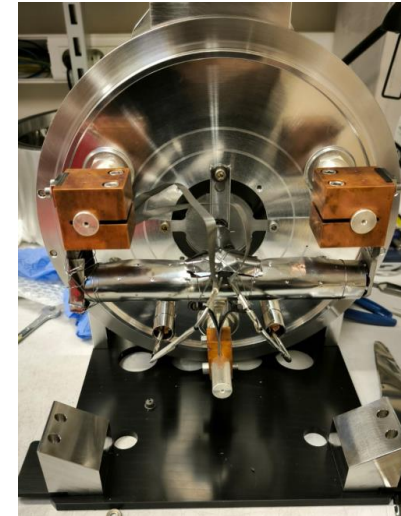
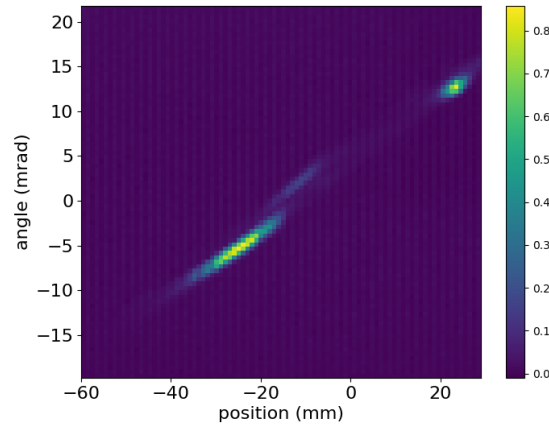
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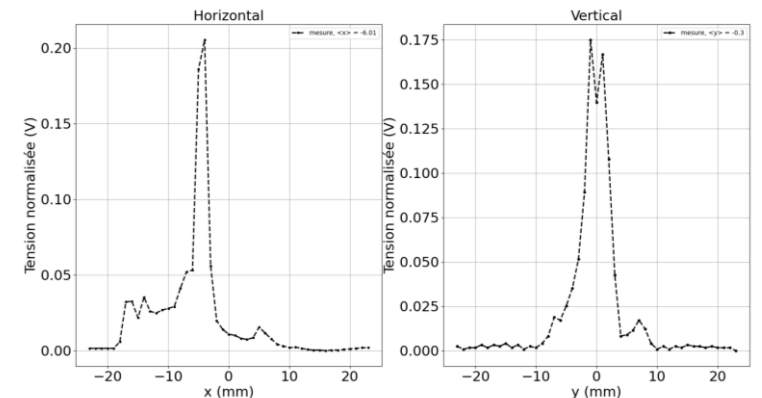
« Large » beam  
in Horizontal plan



« Small » beam  
in Horizontal plan



Profile measurement

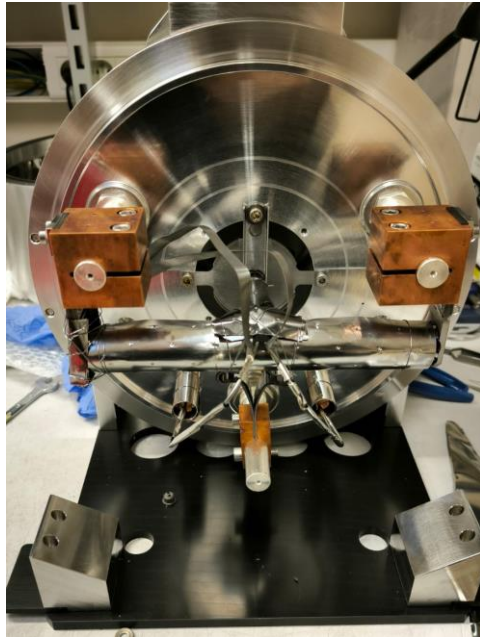




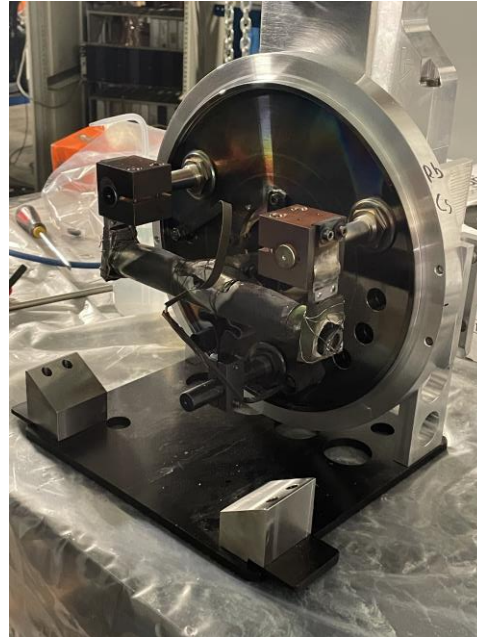
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Study of target-ion source different :

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After 1 week

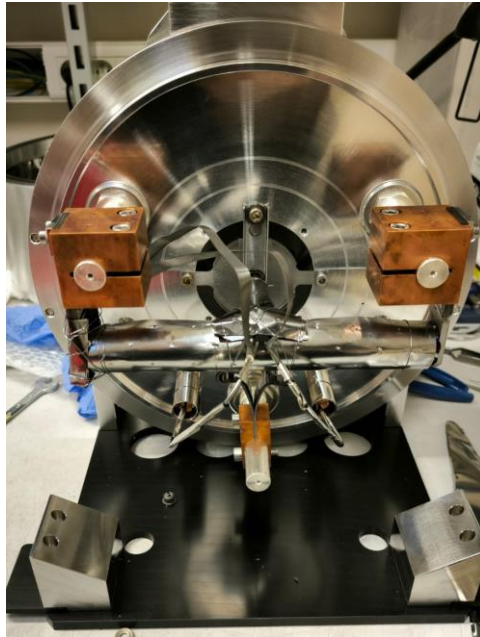




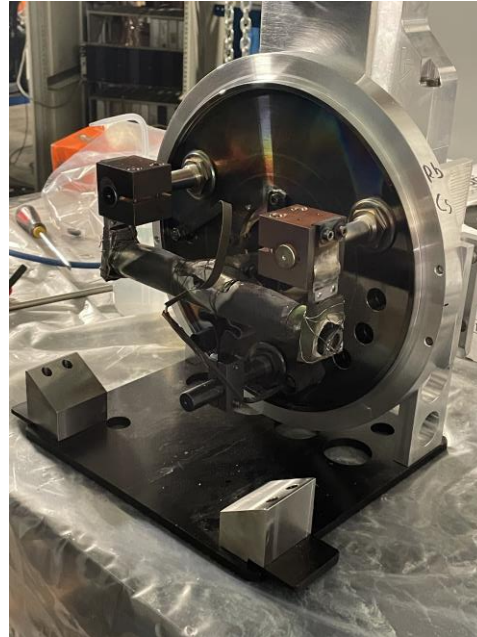
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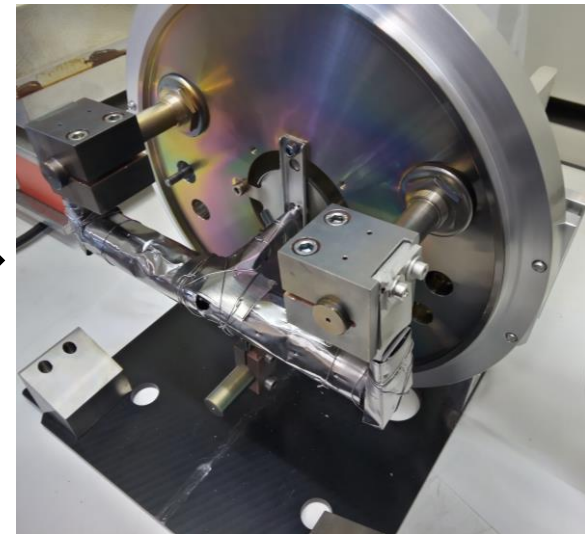
- Additional oven withdraw
- Target of C doped with Cs used in oven to simulate radioactive beam



After 1 week



Last Friday





- **MLLTRAP :**
  - Beam line soon connected to the traps
  - Helium recuperation still has to be tested with MLLTRAP
  - Stabilisation of magnet temperature
  
- **RFQCB :**
  - Electronics needed to start testing
  - Calculations :
    - Decoupling of injection and extraction
    - Effect of  $q$  parameter
    - Effect of grouped particles
    - Buncher
  
- **Emittance analysis :**
  - Influence of beam shape to study further
  - Checking errors
  
- **Perspectives :** Transport calculations from target-ion source to exit of RFQCB

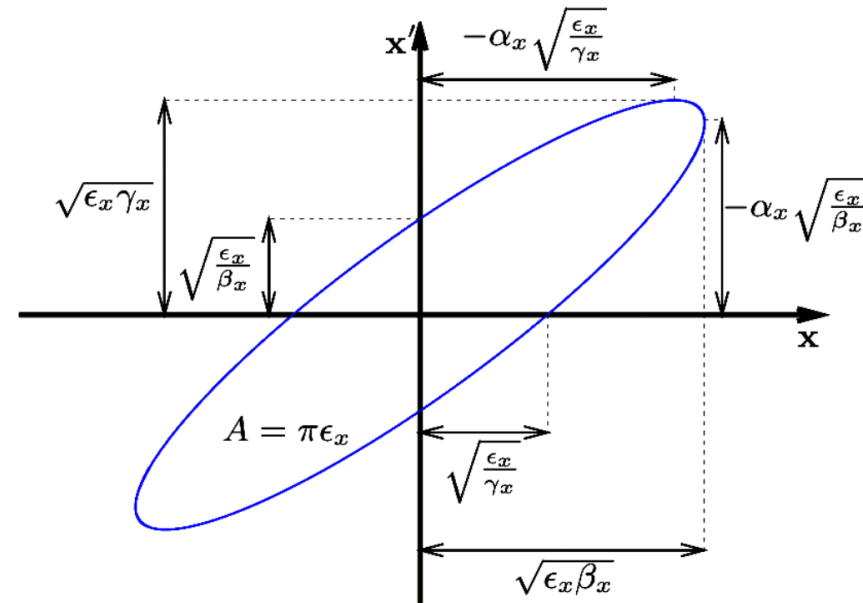
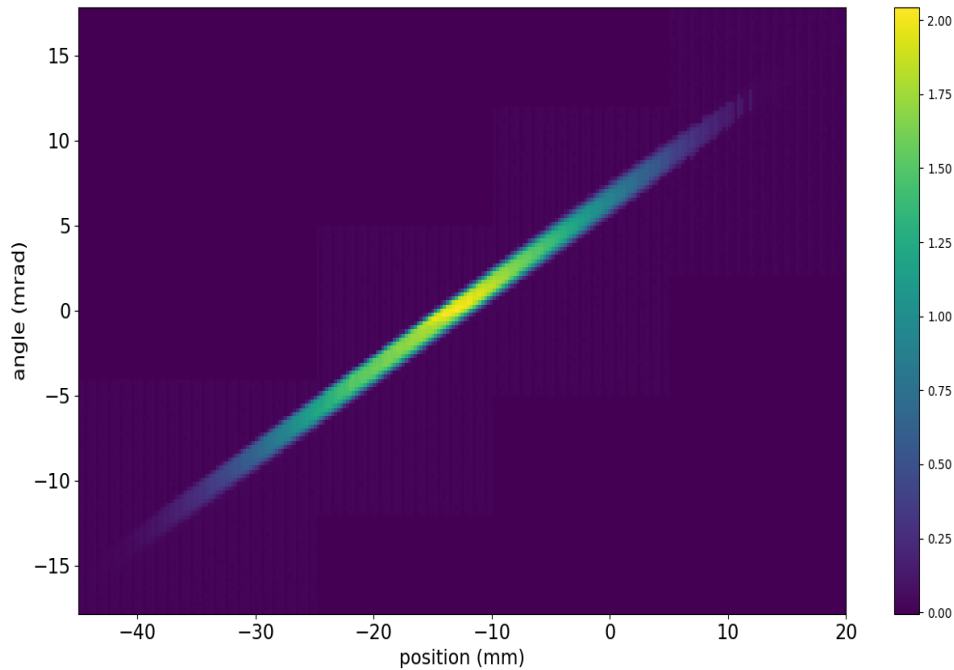


**Thank you for your attention**



# Emittance

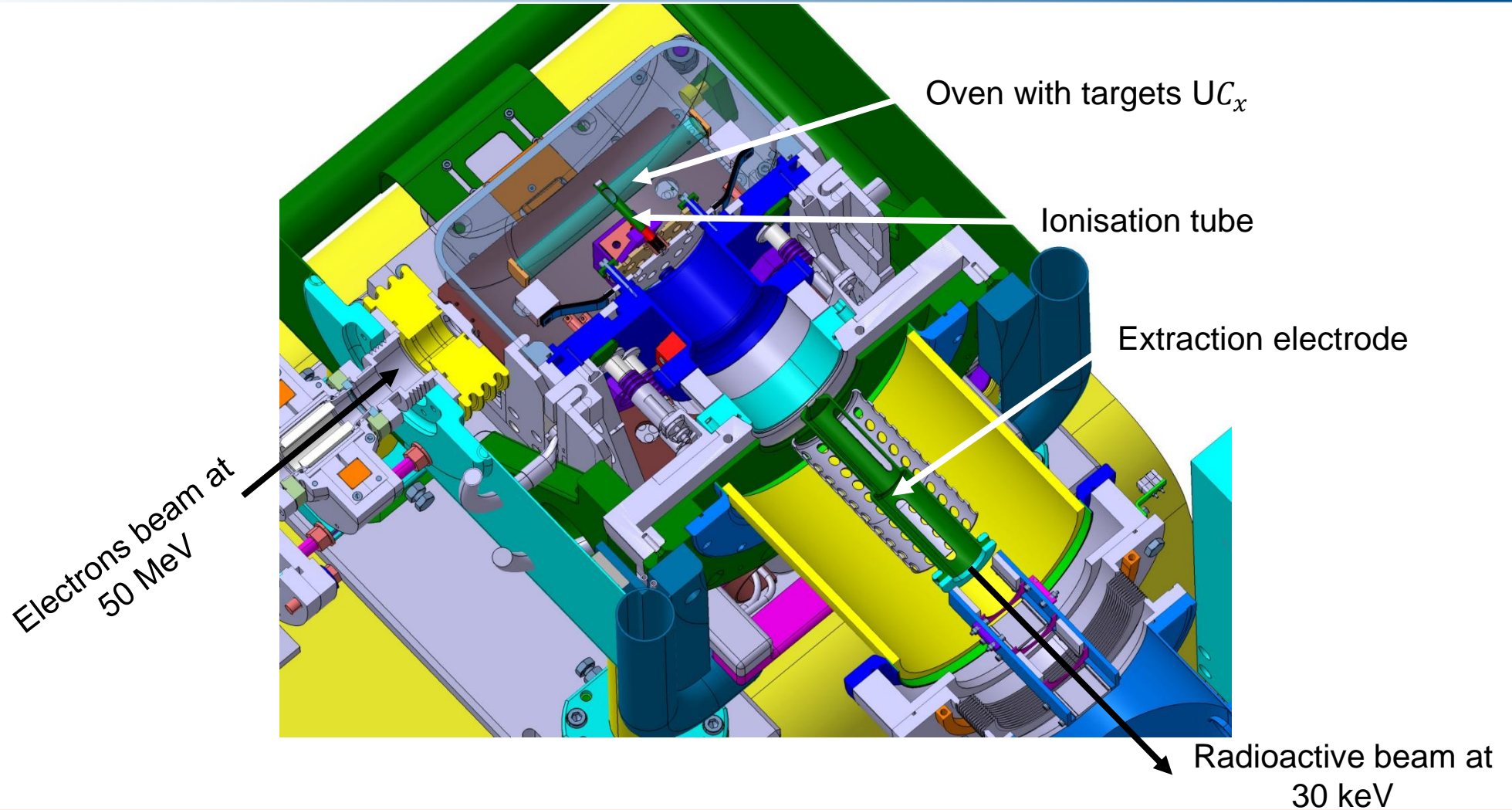
- **Emittance** : surface representing all the points in the phase space of the particles of the beam, with a factor of  $\pi$ .
- **Twiss parameters** :  $\epsilon = \gamma x^2 + 2\alpha x x' + \beta x'^2$



**Emittance is conservative**



# Target-ion source







## Used definitions:

$$\epsilon_{rms} = \sqrt{\sigma_x^2 \sigma_{x'}^2 - \sigma_{xx'}^2}$$

$$\sigma_x = \sqrt{w(x^2) - w(x)^2}$$

$$\sigma_{x'} = \sqrt{w(x'^2) - w(x')^2}$$

$$\sigma_{xx'} = w([x - w(x)][x' - w(x')])$$

$$w(x) = \frac{\sum_i x_i I_i}{\sum_i I_i}$$

## Associated errors calculations:

$$\delta\epsilon = \sqrt{\left(\frac{\sigma_x \sigma_{x'}^2}{\epsilon}\right)^2 \delta\sigma_x^2 + \left(\frac{\sigma_{x'} \sigma_x^2}{\epsilon}\right)^2 \delta\sigma_{x'}^2 + \left(\frac{\sigma_{xx'}}{\epsilon}\right)^2 \delta\sigma_{xx'}^2}$$

$$\delta\sigma_{xx'} = \sqrt{\sum_i \left(\frac{\partial\sigma_{xx'}}{\partial x_i}\right)^2 \delta x_i^2 + \sum_i \left(\frac{\partial\sigma_{xx'}}{\partial x'_i}\right)^2 \delta x_i'^2 + \sum_i \left(\frac{\partial\sigma_{xx'}}{\partial I_i}\right)^2 \delta I_i^2}$$

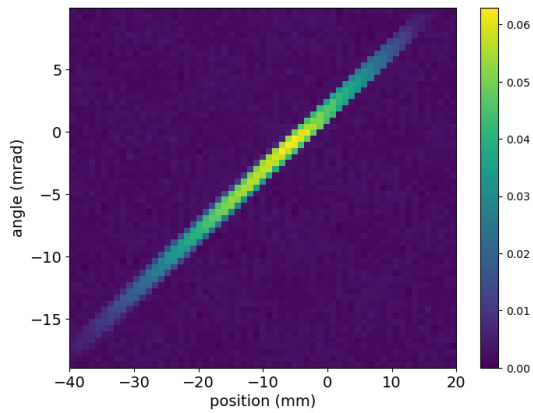
$$\delta\sigma_x = \sqrt{\left(\frac{1}{2\sigma_x}\right)^2 \delta w^2(x^2) + \left(\frac{w(x)}{\sigma_x}\right)^2 \delta w^2(x)}$$

$$\delta w = \sqrt{\sum_i \left(\frac{\partial w}{\partial x_i}\right)^2 \delta x_i^2 + \sum_i \left(\frac{\partial w}{\partial I_i}\right)^2 \delta I_i^2}$$

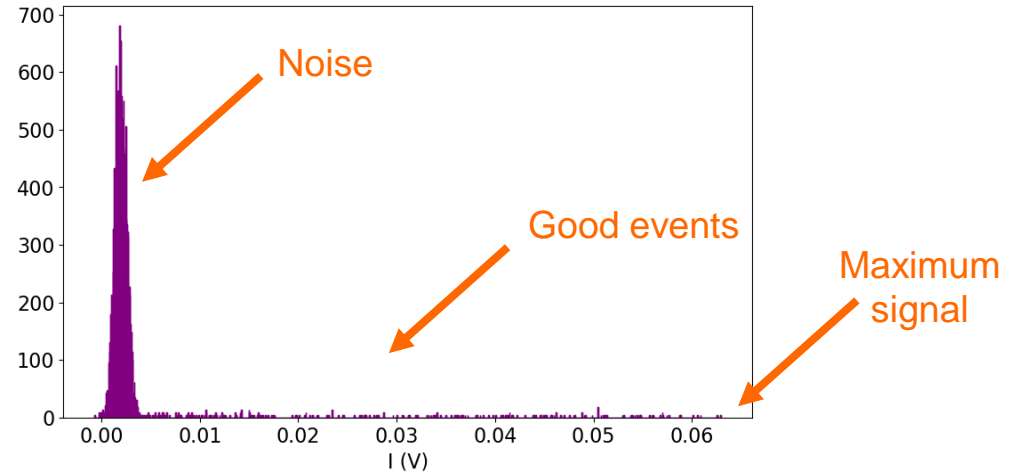
$$\begin{aligned} \delta x &= 10 \mu\text{m} \\ \delta x' &= 0,025 \text{ mrad} \\ \delta I &= 9 \cdot 10^{-6} \text{ V} \end{aligned}$$



# Emittance measurements analysis



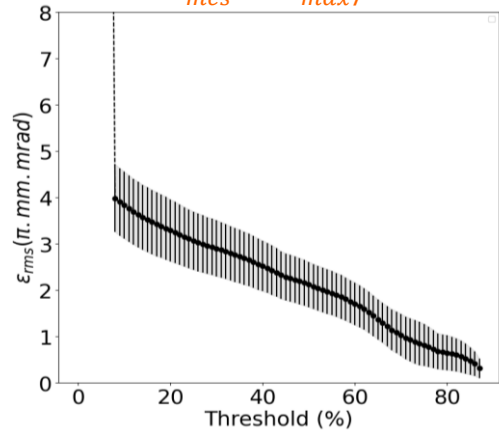
Distribution of the signal intensity



## Noise substraction :

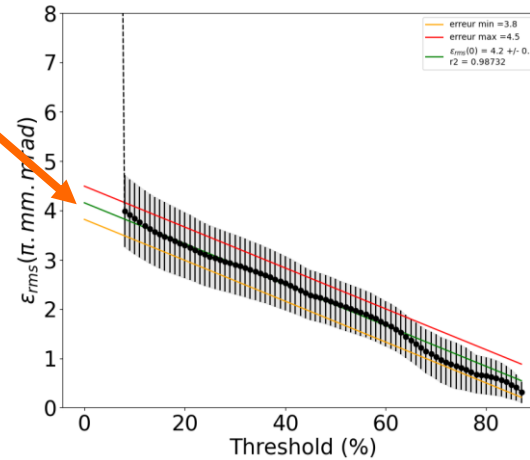
Threshold of maximum signal :

$$I = I_{mes} - nI_{max}/100$$



Linear regression

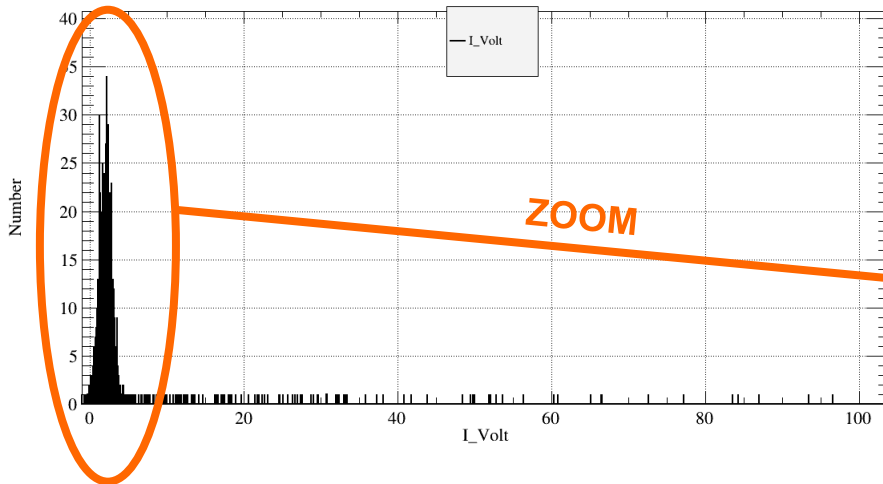
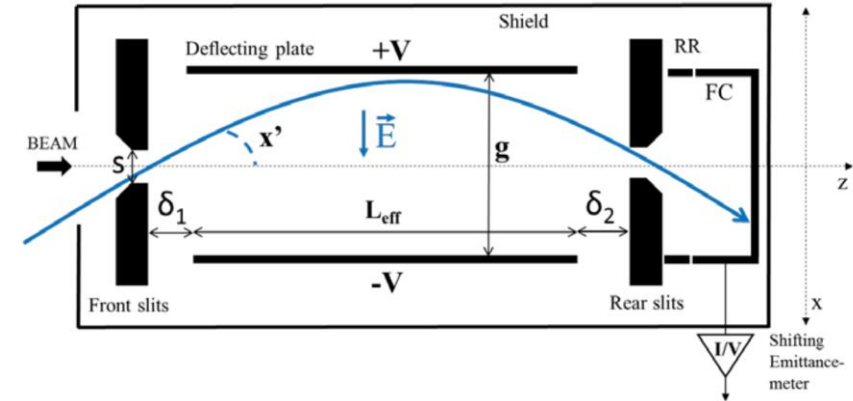
Value of emittance



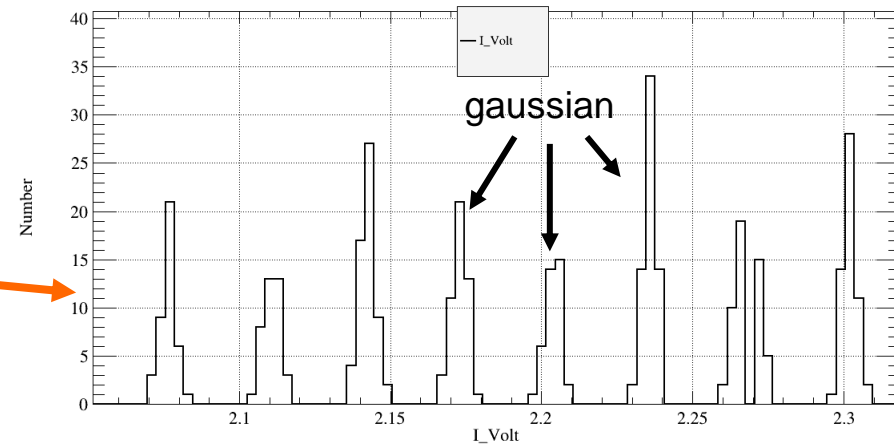


# Emittance measurements errors

- Position error: stepper motor precision  
➔  $\delta x = 10 \mu\text{m}$
- Angular error: voltage supplier precision  
➔  $\delta x' = 0,025 \text{ mrad}$
- Measured intensity error: electronics precision



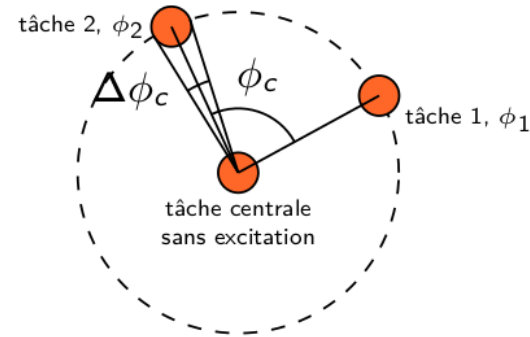
➔  $\delta I = 3 \times 3.10^{-6} \text{ V}$





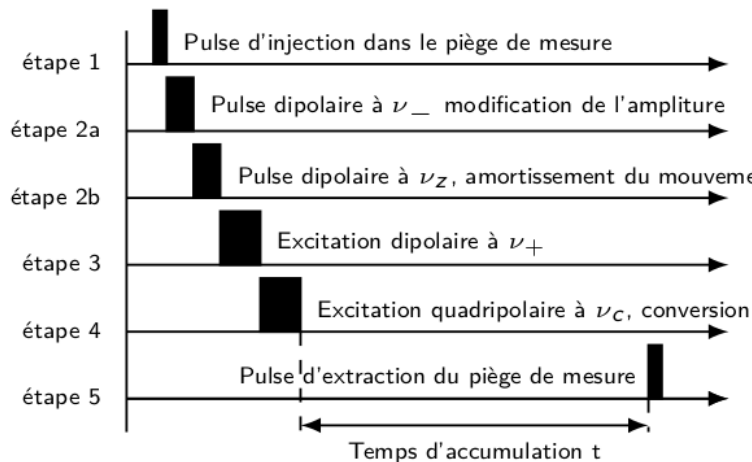
# Phase-Imaging Ion-Cyclotron-Resonance (PI-ICR)

- Projection des mouvements propres des ions sur un détecteur sensible à la position transverse, une galette à microcanaux avec des lignes à retard
- $\phi_c + 2\pi(n_+ + n_-) = 2\pi\nu_c t$
- Pouvoir de séparation :  $\Delta\nu_c = \frac{\Delta\phi_c}{2\pi t_{acc}}$



S. Eliseev et al., Appl. Phys. B, 114 (2014) 107-128

## Mesure de la phase $\phi_1$



## Mesure de la phase $\phi_2$

